

DIPLOMA

awarded to the

NATIONAL INSTITUTE OF RESEARCH AND DEVELOPMENT FOR OPTOELECTRONICS INOE 2000

in recognition of the invention:

Nanostructured thin films based on carbo-nitrides if transition metals with silicon additions resistant to wear

Authors:

Spiridon Dragomir, Anca C. Parau, Diana M. Vranceanu, Lidia R. Constantin, Claudia P. Dragomir, Alina Vladescu

presented at the 16th International Invention and Innovation Show INTARG® 2023

Edyta Demby-Siwek

President of the Patent Office of the Republic of Poland